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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Naoki YOSHIOKA, et al.**

Serial No.: **Not Yet Assigned**

Filed: **September 21, 2001**

For: **LIQUID SUBSTANCE SUPPLY DEVICE FOR VAPORIZING SYSTEM, VAPORIZER, AND VAPORIZATION PERFORMANCE APPRAISAL METHOD**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

September 21, 2001

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

Copies of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,
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Enclosures: PTO-1449; References (3)

**INFORMATION
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U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA					
	AB					
	AC					
	AD					
	AE					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
	AF 5-253402	10/05/93	Japan	No.
	AG 11-345774	12/14/99	Japan	Abstract
	AH WO 94/21840	09/24/94	PCT	
	AI			
	AJ			

OTHER DOCUMENTS

Examiner	AK	
	AL	

Date Considered